



501.37120X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): K. TSUBOSAKI et al  
Serial No.: 09/308,620  
Filed: July 20, 1999  
For: SEMICONDUCTOR DEVICE AND MANUFACTURING  
METHOD THEREOF  
Group: 2811  
Examiner: L. THAI

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And  
J. McNeill  
7/30/02

**AMENDMENT**

**Box AF**

Assistant Commissioner of Patents  
Washington, D. C. 20231

July 18, 2002

Sir:

Further to the filing of the Notice of Appeal on March 18, 2002, for which extension is requested in the accompanying Petition for Extension of Time, and responsive to the Final Office Action, dated October 17, 2001, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**IN THE SUBSTITUTE SPECIFICATION:**

On Page 1, please amend the third paragraph, covering lines 16-23, as follows: